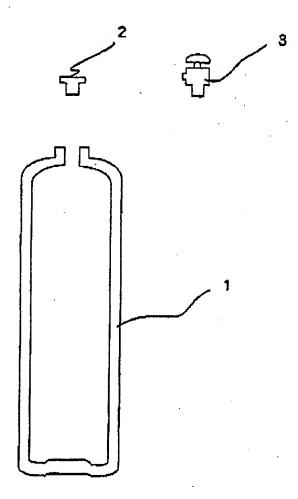
APPLN. FILING DATE: AUGUST 5, 2003
TITLE: PROCESSING METHOD FOR HIGH PRESSURE GAS
CONTAINER AND HALOGEN CONTAINING GAS FILLED ETC.

Inventor(s): Akio KIKKAWA et al. Docket No: 018765-143

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Fig. 1



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